

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	9570	MTJ and MRAM and mixture and argon and mask and pattern and etch and gas and plasma and ratio and magnetic and tunnel and junction	USPAT	OR	ON	2004/12/19 14:31
L2	932	MTJ and MRAM and mixture and argon and mask and pattern and etch and gas and plasma and ratio and magnetic and tunnel and junction and boron and trichloride	USPAT	OR	ON	2004/12/19 14:31
L3	0	2 and (etching adj gas) and (additive adj gas) and mask	USPAT	OR	ON	2004/12/19 14:32
L4	0	2 and (etching adj gas) and (addition adj gas) and mask	USPAT	OR	ON	2004/12/19 14:33
L5	0	2 and (etching adj gas) and (mask adj pattern)	USPAT	OR	ON	2004/12/19 14:33
L6	2	2 and (etching adj gas)	USPAT	OR	ON	2004/12/19 14:36
L7	0	(etching adj gas) and MTJ and MRAM and (main adj gas)	USPAT	OR	ON	2004/12/19 14:37
L8	0	(etching adj gas) and MTJ and MRAM	USPAT	OR	ON	2004/12/19 14:37
L9	13	MTJ and MRAM and etch and gas	USPAT	OR	ON	2004/12/19 15:10
L10	6	MTJ and MRAM and etch and gas and mask and material	USPAT	OR	ON	2004/12/19 14:55
L11	1	("6821907").PN.	USPAT	OR	OFF	2004/12/19 14:55
L12	1	11 and (MTJ or MRAM or memory or cell or magnetic or tunnel or junction or mixture or gas or plasma or etch or etching or ratio or mask or pattern or material or coupled or apparatus or argon or power or source or main or addition or additive or boron or trichloride or bias or voltage or magnetic)	USPAT	OR	ON	2004/12/19 15:03
L13	1	("6605836").PN.	USPAT	OR	OFF	2004/12/19 15:03
L14	1	13 and (MTJ or MRAM or memory or cell or magnetic or tunnel or junction or mixture or gas or plasma or etch or etching or ratio or mask or pattern or material or coupled or apparatus or argon or power or source or main or addition or additive or boron or trichloride or bias or voltage or magnetic)	USPAT	OR	ON	2004/12/19 15:09

L15	1	("6806127").PN.	USPAT	OR	OFF	2004/12/19 15:09
L16	1	15 and (MTJ or MRAM or memory or cell or magnetic or tunnel or junction or mixture or gas or plasma or etch or etching or ratio or mask or pattern or material or coupled or apparatus or argon or power or source or main or addition or additive or boron or trichloride or bias or voltage or magnetic)	USPAT	OR	ON	2004/12/19 15:09
L17	2058	438/3	USPAT	OR	ON	2004/12/19 15:10
L18	412	438/73	USPAT	OR	ON	2004/12/19 15:10
L19	224	438/709	USPAT	OR	ON	2004/12/19 15:10
L20	1615	438/710	USPAT	OR	ON	2004/12/19 15:11
L21	881	438/712	USPAT	OR	ON	2004/12/19 15:16
L22	370	438/729	USPAT	OR	ON	2004/12/19 15:16
L23	156	438/732	USPAT	OR	ON	2004/12/19 15:16

12/19/04